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# A novel MoS<sub>2</sub>-based hybrid film as the back electrode for high-performance thin film solar cells†

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MoS<sub>2</sub>, a representative two-dimensional transition metal dichalcogenide, gains significant interest due to its unique layered structure and electronic structure. In this work, a novel MoS<sub>2</sub>-based hybrid thin film was constructed by disordered stacking of MoS<sub>2</sub>-NMP hybrid particles, which were mainly composed of MoS<sub>2</sub>(NMP)<sub>3</sub> molecules stacking in a nearly-parallel manner through S··H–C hydrogen bonds. Interestingly, it presents a higher work function (5.42 eV) than Au (5.32 eV), and a unique thickness-dependent conductivity with p-type semiconductor characteristic. Using it as the back contact of CdTe solar cells, the efficiency was improved by 2.6% compared to the traditional cells, mainly from the great improvement in short-circuit current density (*J*<sub>sc</sub>). This significant improvement in solar performance was ascribed to the matchable energy levels at the CdTe/MoS<sub>2</sub>-based thin film interface and its unique thickness-dependent conductivity. This work opens a new direction for the extensive applications of TMD-based materials.

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## Introduction

Recently, two-dimensional transition metal dichalcogenides (TMD), such as MoS<sub>2</sub>, WS<sub>2</sub>, WSe<sub>2</sub>, *etc.*,<sup>1–4</sup> have gained significant interest, because of their impressive electronic, photonic and chemical properties, and large natural abundance.<sup>2,4–7</sup> As a typical representative, MoS<sub>2</sub> has been widely applied in solar cells, photocatalytic, electrocatalytic, biosystems and photodetector devices.<sup>7–13</sup> The great popularity of MoS<sub>2</sub> not only depends on its intrinsic bulk properties, but also significantly depends on its tunable electronic properties due to its unique crystal structure. In a representative hexagonal structure (*P*6<sub>3</sub>/*mmc*), Mo and S atoms are covalently bonded in S–Mo–S molecular layers, which stack together *via* weak van der Waals (vdW) interactions along the *z* axis to form the bulk material. The strong intra-layer and weak inter-layer interactions bring with the high anisotropy of MoS<sub>2</sub>, which also make it possible to exfoliate the bulk MoS<sub>2</sub> into few layers, even single layer. With the dimension decrease from 3D to 2D, the band gaps, electronic structures and work functions of MoS<sub>2</sub> greatly vary. For example, the band structures are significantly changed from an indirect band gap of 1.29 eV to a direct band gap of 1.90 eV as we thin down the 2D layers to the single-layer limit.<sup>14</sup> So 2D TMDs provide a great platform of tuning material properties towards

desired functions, further attracting a great deal of attention and opening up opportunities for a wide range of applications.

Cadmium telluride (CdTe) solar cells have taken a largest market share in all compound thin film solar cells because of the low cost, high efficiency, long-term stability, and large-scale applications. Nevertheless, there are still many problems to hinder its efficiency improvement. The significant one is the issue of the back contact owing to the high work function (5.7 eV) and high electron affinity (4.5 eV) of CdTe.<sup>15–17</sup> Commonly used metal thin films, such as Ag, Al, and *etc.*, own lower work function than that of CdTe, and could not directly match with CdTe layer to construct a good ohmic contact. To solve this problem, various materials with high work functions are used as the back contact, such as MoO<sub>3</sub>,<sup>18,19</sup> Sb<sub>2</sub>Te<sub>3</sub>,<sup>20,21</sup> V<sub>2</sub>O<sub>5</sub>,<sup>17</sup> HgTe,<sup>16</sup> *etc.* Our group has devoted a lot of efforts to searching for new back contact materials. And a series of materials, such as ALD–Al<sub>2</sub>O<sub>3</sub>, CuAlO<sub>x</sub> and Cu<sub>9</sub>S<sub>5</sub>, were found to be beneficial to improve the efficiency.<sup>22–24</sup> Because MoS<sub>2</sub> exhibits layer-number-dependent electronic structure and work functions, we predict that few layers or single layer of MoS<sub>2</sub> might be a potential candidate for the back contact material to implement a good ohmic contact and the efficiency improvement.

In this work, we tried to fabricate single layer or few layers of MoS<sub>2</sub> by liquid phase exfoliating method at first,<sup>9,25</sup> but unexpectedly discovered that MoS<sub>2</sub> can be dissolved in *N*-methyl-2-pyrrolidone (NMP). So a novel MoS<sub>2</sub>-based hybrid thin film was found for the first time, which was fabricated by spin-coating and subsequent thermal treatment as a new back contact material for CdTe thin-film solar-cells. Interestingly, it

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was found to be a p-type semiconductor thin film with higher work function (5.42 eV) than Au with tunable conductivity with thickness. When applied it as the back contact in CdTe solar cell, a short-circuit current density ( $J_{sc}$ ) improvement, by 3.7 mA  $\text{cm}^{-2}$  than the traditional cells, was implemented, which brought with a great efficiency improvement of 2.6%. After a careful and systematic study, this great improvement could be ascribed to the high work function of MoS<sub>2</sub>-based complex thin film with the matching energy level structures between it and CdTe layer for enhancing  $J_{sc}$ . This work not only provides a new and effective material system for the efficiency improvement of solar cells, but also opens a new research direction for the applications of TMDs.

## Experimental procedures

### Preparation of MoS<sub>2</sub>-NMP solution

0.5 g of MoS<sub>2</sub> powders (99.9%, Aladdin) was added into 40 mL *N*-methyl-2-pyrrolidone solvent (NMP, 99.9%, Aladdin). The mixture was stirred to dissolve at 70 °C for 12 h. Then the suspension was centrifuged at 8000 rpm for 15 minutes. We gained black precipitate and faint yellow solution (MoS<sub>2</sub>-NMP solution). Faint yellow solution was collected and used to fabricate the back contact of CdTe solar cells. Solution was further verified by nanometer particle size analyzer, which can distinguish the minimum size of particle is 0.3 nm. No nanometer particle was detected in the solution.

### Fabrication of CdTe solar cells

Commercial soda lime glass substrates coated with fluorine-doped tin oxide (FTO-glass) was purchased, which had a sheet resistance of 35  $\Omega \text{ sq}^{-1}$  and a transmittance of about 85%. Then they were cleaned in an ultrasonic bath using de-ionized water and acetone. About 100 nm-thick CdS window layer was deposited on FTO-glass by radio frequency magnetron sputtering using argon gas with a 4N purity (99.99%). CdTe layers were deposited *via* close space sublimation (CSS). CdTe source and substrate was under 650 °C and 580 °C, respectively. A thickness of about 4  $\mu\text{m}$  for CdTe layer was gained. To encourage CdTe grains growth, passivate grain boundaries of CdTe and improve the CdS/CdTe interface,<sup>26–28</sup> CdCl<sub>2</sub> treatment was performed. Samples were soaked in a 70%-saturated CdCl<sub>2</sub> methanol solution for 15 minutes. Then they were annealed at 390 °C for 30 minutes. In order to CdTe form Te-rich layer on the surface of CdTe layer, samples were etched with nitric-phosphoric acid for 30 s. Following etching treatment, a 3 nm-thick Cu layer was evaporated on Te-rich layer by vacuum evaporation. Then MoS<sub>2</sub>-NMP solution was spin-coated on Cu layer surface, following by a thermal treatment on hot plate at 200 °C. Then samples were annealed under 150 °C for 30 minute. Finally an Au back electrode with thickness of 30 nm and area of 0.3  $\text{cm}^2$  was deposited by vacuum evaporation.

### Characterizations

XPS measurements were carried out in a Thermo Scientific K-Alpha system, equipped with an Al X-ray source ( $K\alpha$ , 1486.6

eV). For device etching, a 2 kV Ar<sup>+</sup> ion gun was used to etch 30 levels (60 s for each level), and XPS scans were acquired in between each etching step. Peak fitting was carried out using Thermo Avantage software.

UV-Vis transmission spectrum was measured by a UV-2450 spectrophotometer. Then UV-Vis absorption spectrum was obtained from the transmission spectra by Beer-Lambert Law ( $A = \lg(1/T)$ ,  $A$  and  $T$  separately represents absorbance and transmittance).

The work function of MoS<sub>2</sub>-based film was measured using a Bruker MultiMode 8 atomic force microscopy (AFM). The electrical potential of MoS<sub>2</sub>-based film can be characterized by Kelvin probe force microscopy (KPFM) technology. So AFM images and KPFM potential signals were obtained simultaneously by KPFM technology.

Mass spectrometry were measured by a QSTAR Elite Hybrid LC/MS/MS System with the ESI ion source.

The surface and cross-sectional views of devices were characterized by Zeiss SUPRA-55 scanning electron microscope (SEM).

Both the current-voltage characteristic and high frequency  $C-V$  curve were measured by a KEYSIGHT B1500A semiconductor device analyzer combined probe station separately using a FTO/MoS<sub>2</sub>-based film/Au structure and a FTO/MoS<sub>2</sub>-based film/Al<sub>2</sub>O<sub>3</sub>/Au MOS structure. Thereinto, FTO and Au were used as electrodes. The current-voltage characteristic was carried out under a scan rate of 100  $\text{mV s}^{-1}$ . High frequency  $C-V$  signals were acquired under 1 MHz frequency and a scan rate of 100  $\text{mV s}^{-1}$ .

Photocurrent density-voltage characteristics of devices were measured under AM 1.5 illumination by ABET sun 3000 solar simulator. And the light power of simulator was calibrated to one sun light intensity by using a NREL-calibrated Si cell (Oriol 91150). External quantum efficiency was measured under 300 W Xe lamp with a Zolix solar cell scan 100 QE/IPCE measurement system.

## Results and discussion

### The phase and composition of MoS<sub>2</sub>-based hybrid thin film

MoS<sub>2</sub>-based hybrid thin film was formed and its phase and composition were investigated. In a typical fabrication procedure of MoS<sub>2</sub>-based thin film, MoS<sub>2</sub> powder was dissolved in *N*-methyl-2-pyrrolidone (NMP) to form MoS<sub>2</sub>-NMP solution. MoS<sub>2</sub>-based film was produced by spin-coating method with the MoS<sub>2</sub>-NMP solution.

At first, we analysed the composition of MoS<sub>2</sub>-based thin film. According to the work of Ye group,<sup>9</sup> single layer of MoS<sub>2</sub> could be obtained from MoS<sub>2</sub>-NMP suspension by centrifuged at 4000 rpm for 45 min. In our experiment, the MoS<sub>2</sub>-NMP solution used for spin-coating was obtained after a centrifugation at 8000 rpm for 15 min. So it could be derived that even single layer of MoS<sub>2</sub> would not be found in the residue MoS<sub>2</sub>-NMP solution. It was confirmed by nanometer particle size analyzer.

Then we performed the powder XRD analysis on the raw material MoS<sub>2</sub> and the MoS<sub>2</sub>-based film (with thickness of about



20  $\mu\text{m}$  especially for XRD analysis). As shown in Fig. 1a. It is clear that the raw material presents a strong peak of (002), indicating many layers of  $\text{MoS}_2$  stacked along the  $c$  direction. This is the typical character for bulk  $\text{MoS}_2$ . For  $\text{MoS}_2$ -based thin film, it presents an amorphous character with two board peaks centered at  $11^\circ$  and  $19^\circ$ .

Raman spectra were also recorded for  $\text{MoS}_2$  and  $\text{MoS}_2$ -based thin film. As shown in Fig. 1b, two strong peaks represent two kinds of vibration modes,  $E_{2g}$  and  $A_{1g}$ , for  $\text{MoS}_2$ . But there is no observation for these two peaks in  $\text{MoS}_2$ -based film, which also means that there is no or too little  $\text{MoS}_2$  layer in the film. Two broad peaks centered at  $1370$  and  $1586\text{ cm}^{-1}$  were identified as the D and G peaks for C. This means much C in the  $\text{MoS}_2$ -based film, which might be decomposed from NMP molecules after the irradiation of laser beam. The band gap of  $\text{MoS}_2$ -based thin film was calculated as  $2.14\text{ eV}$  according to the UV-Vis transmission spectrum (Fig. S1 $\dagger$ ). It is definitely larger than the band gaps of bulk  $\text{MoS}_2$  or few layers or single layer of  $\text{MoS}_2$ , which hints that a new material was formed.

In order to further figure out the composition of  $\text{MoS}_2$ -based thin film, the XPS spectra were performed on  $\text{MoS}_2$ -based thin films. As shown in Fig. 1c and d, the peaks of Mo 3d and S 2p were observed, confirming the existence of Mo and S elements. Interestingly, the binding energy of Mo  $3d_{5/2}$  and S  $2p_{3/2}$  peaks are  $232.7$  and  $168.5\text{ eV}$ , respectively, much higher than the standard values ( $229.7$  and  $162.5\text{ eV}$ ) in bulk  $\text{MoS}_2$  (Fig. S2 $\dagger$ ). These results indicated that Mo and S atoms in  $\text{MoS}_2$ -based thin film have different chemical environment with those in  $\text{MoS}_2$

powder. The thermogravimetric analysis (Fig. S3 $\dagger$ ) was also conducted and showed that the rapid decomposition temperature was about  $330^\circ\text{C}$ . According to this result, we performed thermal decomposition experiment in an Ar-filled glovebox at  $430^\circ\text{C}$ . The powder XRD pattern of decomposed product was shown in Fig. S4 $\dagger$ , which indicated the coexistence of the pyrolysis carbon and  $\text{MoS}_2$ . So we could conclude that the film was composed with much NMP and little  $\text{MoS}_2$ .

Then another question arises. What is the basic structure unit of  $\text{MoS}_2$ -based thin film? How to form  $\text{MoS}_2$ -based thin film from the  $\text{MoS}_2$ -NMP solution, which is made by  $\text{MoS}_2$  bulk materials to be dissolved in NMP solvent? IR spectrum was used to track the whole fabrication process of the  $\text{MoS}_2$ -based thin film. As shown in Fig. 1e, IR spectra of NMP,  $\text{MoS}_2$ ,  $\text{MoS}_2$ -NMP solution and  $\text{MoS}_2$ -based thin film were all recorded. There is no obvious peak in the spectra of  $\text{MoS}_2$ , which is in consistent with the infrared transmission character of sulfides.<sup>29</sup> In the spectra of NMP, the bands at  $2944$  and  $2873\text{ cm}^{-1}$  were respectively assigned to asymmetric ( $\nu_{\text{as}}$ ) and symmetric stretching vibrations ( $\nu_{\text{s}}$ ) of  $\text{CH}_3$  and  $\text{CH}_2$ ; the bands at  $1370$ – $1530\text{ cm}^{-1}$  responded to the bending vibrations of  $\text{CH}_3$  and  $\text{CH}_2$  ( $\delta$ ); the bands at  $745\text{ cm}^{-1}$  were ascribed to the deformation vibrations of  $\text{CH}_2$  ( $\rho$ ); the character band for the stretching vibration of  $\text{C}=\text{O}$  was located at  $1675\text{ cm}^{-1}$  ( $\nu$ );<sup>30</sup> the band at  $1296\text{ cm}^{-1}$  was assigned to the stretching vibration of  $\text{C}-\text{N}$  ( $\nu$ ). When comparing the spectra between NMP and  $\text{MoS}_2$ -NMP solution, they are basically the same except the broad band at  $3515\text{ cm}^{-1}$ . We assigned this broad band to the hydrogen bond formation ( $\text{S}\cdots\text{H}-\text{C}$ ) between S atoms in  $\text{MoS}_2$  molecule with the H atom of  $\text{CH}_2$  and  $\text{CH}_3$  in NMP.<sup>31,32</sup> When obtaining the solid  $\text{MoS}_2$ -based film after evaporating the free solvent NMP molecules, we could find the symmetric stretching vibration ( $\nu_{\text{s}}$ ) of  $\text{CH}_3$  and  $\text{CH}_2$  at  $2873\text{ cm}^{-1}$  are disappearing, which could be ascribed to the formation of the  $\text{S}\cdots\text{H}-\text{C}$  hydrogen bond, destroying the symmetric stretching vibration of  $\text{CH}_3$  and  $\text{CH}_2$ . In addition, all the other bands, including  $\nu(\text{S}\cdots\text{H}-\text{C})$ ,  $\nu(\text{C}=\text{O})$ , and  $\nu(\text{C}-\text{N})$ , moved to the direction of the low wavenumber, which is consistent with the conversion from solution state to solid state because of the formation of solid film. Especially, the bands of  $\delta(\text{CH}_3, \text{CH}_2)$  merged to two board bands, which significantly moved to lower wavenumber because of the formation of hydrogen bond  $\text{S}\cdots\text{H}-\text{C}$ . So we could deduce that the basic structural unit of  $\text{MoS}_2$ -based thin film contain  $\text{MoS}_2$  and NMP.

Till now, we still do not know the molar ratio of  $\text{MoS}_2$  and NMP molecules in  $\text{MoS}_2$ -based thin film. The mass spectrum (MS) was used to solve this problem. The MS spectra of pure NMP reagent and  $\text{MoS}_2$ -NMP solution were presented in Fig. S5 $\dagger$ . As show in Fig. S5b $\dagger$ , two of the highest peaks located at  $351$  and  $461$  could be assigned to  $(\text{NMP})_2\text{S}_4$  and  $\text{MoS}_2(\text{NMP})_3$ , respectively. Owing to the subsequent heating process,  $(\text{NMP})_2\text{S}_4$  might be decomposed or evaporated. So  $\text{MoS}_2(\text{NMP})_3$  was thought to be the main composition of  $\text{MoS}_2$ -based thin film. We proposed three models for the structure of  $\text{MoS}_2$ -NMP $_3$  (Fig. S6 $\dagger$ ). The structure optimization by Gaussian03 was performed based on these three models. The results showed

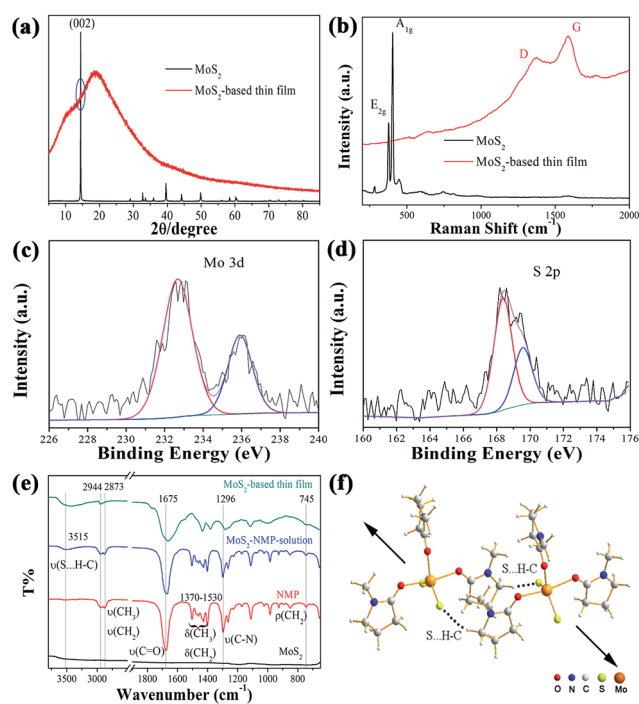


Fig. 1 (a) The powder XRD patterns for  $\text{MoS}_2$  and  $\text{MoS}_2$ -based thin film. (b) The Raman spectra for  $\text{MoS}_2$  and  $\text{MoS}_2$ -based thin film. (c) Mo  $3d_{5/2}$  and (d) S  $2p_{5/2}$ , XPS spectra of  $\text{MoS}_2$ -based thin film. (e) The IR spectra of  $\text{MoS}_2$ , NMP,  $\text{MoS}_2$ -NMP solution and  $\text{MoS}_2$ -based thin film. (f) The proposed model for the composition of  $\text{MoS}_2$ -based thin film.



that only the third one shown in Fig. S6c† could be successfully optimized. The optimized structure was illustrated in Fig. 1f.

Based on all the analysis above, we could conclude that MoS<sub>2</sub>-based complex thin film was constructed by the MoS<sub>2</sub>(NMP)<sub>3</sub> molecules as basic structure unit to stack in a nearly-parallel manner through S···H–C hydrogen bonds shown in Fig. 1f.

### The electrical properties of MoS<sub>2</sub>-based thin film

In order to study the conductivity of MoS<sub>2</sub>-based films, a device shown in Fig. 2a was designed and prepared. Different thicknesses of MoS<sub>2</sub>-based thin films were deposited on FTO-glass substrates by spin-coating. After that, 30 nm-thickness gold films were evaporated on MoS<sub>2</sub>-based films. The current–voltage characteristics of these devices are measured. Samples MoS<sub>2</sub>-NMP-1T (2T, 3T, 4T, 5T) represent MoS<sub>2</sub>-NMP films which was formed through spin-coating once (twice, three, four and five times in spinning-rate of 1200 rpm). It is clear that when MoS<sub>2</sub>-NMP solution was spin-coated twice, the conductivity reached the best. Moreover, the current does not linearly depend on the voltage, exhibiting an obvious semiconductor character. Its resistance was deduced as about 1.67 kΩ according to the current value when the voltage is 1 V. All the resistances were summarized in Fig. 2b. With the increasing of films thickness, the conductivities of films firstly increase and then decrease. This tendency is consistent with that of the efficiency when different thicknesses of NMP-based films are applied in CdTe

solar cells. This indicates that the conductivity of films is positively linked with the performance of solar cells. It is rational that the series resistance of solar cells will increase with the rising resistance of MoS<sub>2</sub>-based films, resulting into the reduction of the PCEs for CdTe solar cells.

In order to determine the type of this semiconductor film, a Metal-Oxide-Semiconductor (MOS) device was fabricated in Fig. 2c. MoS<sub>2</sub>-based thin film was spin-coated twice on FTO-glass substrate. Following this step, 40 nm-thick Al<sub>2</sub>O<sub>3</sub> layer was deposited as dielectric layer by atomic layer deposition (ALD) method. Finally 30 nm-thickness gold was evaporated to complete this MOS structure device, which was used to measure high frequency C–V curve. Fig. 2d shows the high frequency C–V curve. For p-type semiconductor, when bias voltage was positive, semiconductor was in a depletion state. As high frequency signal was applied, the speed of generation and recombination of electron–hole pairs can't come up with that of bias change. So the device capacitance was much small. When bias voltage was negative, holes accumulated on the semiconductor surface. Capacitance C approaches to C<sub>0</sub>. In contrast, the high frequency C–V curve of n-type semiconductor was opposite to p-type semiconductor. The curve shown in Fig. 2d indicates that MoS<sub>2</sub>-based thin film obviously exhibits p-type semiconductor characteristic. According to the p + p model proposed by us before,<sup>22,23</sup> this p-type film is propitious to act as the back contact of CdTe cells.

Work function is also an important parameter to choose the candidate for the back contact materials of CdTe cells. The work function of MoS<sub>2</sub>-based thin film was measured by Kelvin probe of atomic force microscopy (KPFM) method (Fig. 2e), and Au film was used as the standard material. The difference of surface potentials (V) between Au and MoS<sub>2</sub>-based film is about 0.1 V (Fig. 2f). According to the formula below, the work function of MoS<sub>2</sub>-based film was able to be calculated (about 5.42 eV) due to the known work function of Au (5.32 eV).<sup>22,33</sup> Calculation details are presented in the ESI.†

$$\Phi_{\text{sample}} - \Phi_{\text{tip}} = -eV_{\text{CPD}}$$

In summary, MoS<sub>2</sub>-based film is a p-type semiconductor with a high work function, and a promising candidate for the back contact of CdTe solar cells. Moreover, its fancy thickness-dependent conductivity is positively correlated with the variation tendency of the cell performance.

### MoS<sub>2</sub>-based complex thin film as the back contact in CdTe solar cells

Fig. 3a illustrates a typical procedure of device preparation with MoS<sub>2</sub>-based thin film as the back contact. A CdS thin film with thickness of about 100 nm was deposited on FTO-glass by magnetron sputtering. Then a CdTe layer with thickness of about 4 μm was prepared by close space sublimation (CSS), following by evaporating a 3 nm-thickness Cu film. Then MoS<sub>2</sub>-based thin film was prepared by spin-coating and subsequent thermal treatment with different times. Finally the device was completed by evaporating an Au film with thickness of about

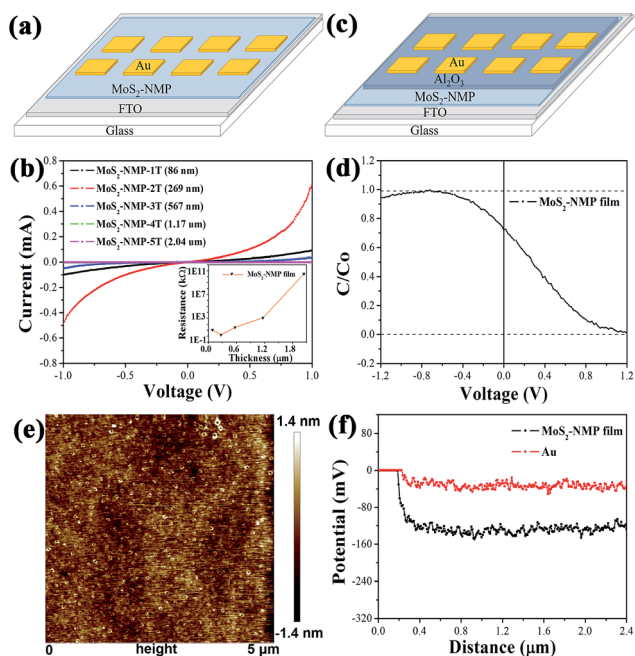


Fig. 2 (a) The device structure which was used to measure the conductivity of MoS<sub>2</sub>-based thin film. (b) The current–voltage curves for MoS<sub>2</sub>-based thin films with different thicknesses. (c) The device structure which was used to measure high frequency C–V of MoS<sub>2</sub>-based thin film. (d) High frequency C–V curve of MoS<sub>2</sub>-based thin films. (e) The AFM height image of MoS<sub>2</sub>-based thin film. (f) Contact potential line scan profiles of MoS<sub>2</sub>-based film and Au film measured by AFM.



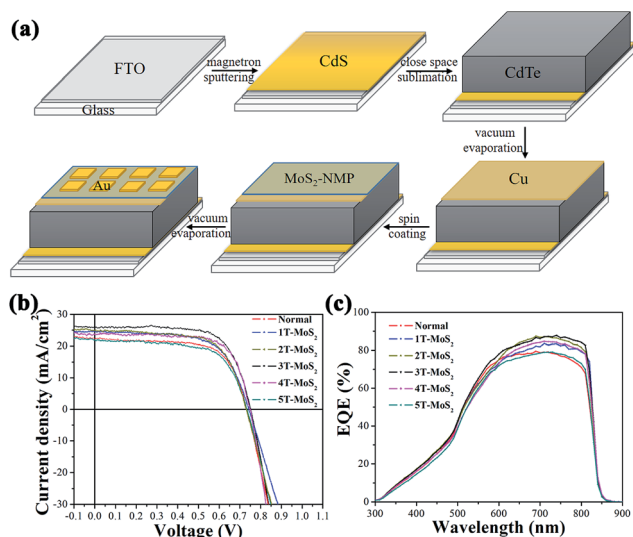


Fig. 3 (a) Fabrication procedure of CdTe solar cells. (b) Current density–voltage ( $J$ – $V$ ) curves of solar cells after spin-coating MoS<sub>2</sub>–NMP solution zero, once, twice, three, four and five times under AM 1.5 illumination. (c) The EQE spectra of corresponding six solar cells.

30 nm as the back electrode. The SEM images for CdTe cells with/without MoS<sub>2</sub>-based thin film as the back contact were presented in Fig. S7.† A compact thin film was observed to completely cover the surface of CdTe layer in Fig. S7d.†

At first, we investigated the impact of the thickness of MoS<sub>2</sub>-based thin film on the efficiency of CdTe solar cells. The traditional CdTe solar cells with the device structure of (FTO/CdS/CdTe/Cu/Au) was used as a reference. According to the different spin-coating times, we finally prepared five cells. 1T-MoS<sub>2</sub>, 2T-MoS<sub>2</sub>, 3T-MoS<sub>2</sub>, 4T-MoS<sub>2</sub> and 5T-MoS<sub>2</sub> respectively represent the cells with MoS<sub>2</sub>-based thin film as back contact prepared by spin-coating 1, 2, 3, 4 and 5 times. As shown in Fig. 3b,  $J$ – $V$  characteristic curves are recorded for all these cells to evaluate their cell performance.

Obviously, the best efficiency occurred when MoS<sub>2</sub>-NMP solution was spin-coated three times. With the further increase of spin-coating times, the performance of cells started to degrade. This tendency is consistent with the conductivity of the MoS<sub>2</sub>-based film. As shown in Fig. 4b. Through the cross-sectional view of the best CdTe cell (3T-MoS<sub>2</sub>), the thickness of MoS<sub>2</sub>-NMP film in 3T-MoS<sub>2</sub> cell was obtained (about 250 nm). When we previously measured the conductivity of the MoS<sub>2</sub>-NMP film, MoS<sub>2</sub>-NMP solution was spin-coated twice, the conductivity of the film is the best. Here, thickness of 2T-MoS<sub>2</sub>-NMP film is about 269 nm (Fig. 2b). We find that although their spin-coating times are different, their thicknesses are almost the same. It was caused by differences in the substrate (one is CdTe/Cu, the other is FTO). It also explains why the efficiency of 3T-MoS<sub>2</sub> cell is the highest. In contrast to the traditional cell, power conversion efficiency was increased from 11.1% to 13.7%. The detailed photovoltaic parameters were listed in Table 1. It is easy to found that the efficiency improvement was mainly from the increasing of short-circuit current ( $J_{sc}$ ) from 22.2 to 25.9 mA cm<sup>-2</sup>. In the meanwhile,

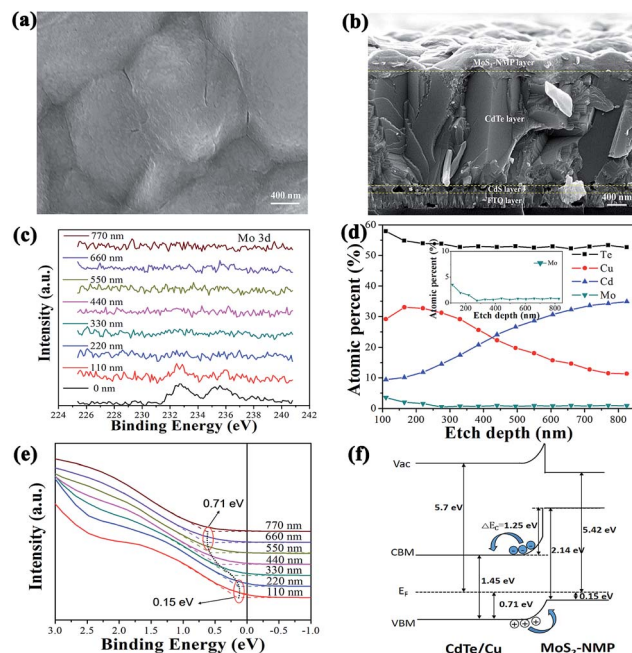


Fig. 4 (a) High magnification SEM image of CdTe surface after spin-coating three times. (b) The cross-sectional view of the best CdTe cell (3T-MoS<sub>2</sub>). (c) The XPS spectra of Mo element with etching depth in CdTe cell (3T-MoS<sub>2</sub>). (d) The atomic percent of Cd, Te, Cu and Mo with etching depth for CdTe cell (3T-MoS<sub>2</sub>). (e) The valence spectra of CdTe cell (3T-MoS<sub>2</sub>) with etching depth. (f) The energy band structure of CdTe solar cells (3T-MoS<sub>2</sub>).

fill factor (FF) and open-circuit voltage also gained further optimization (Table 1). According to external quantum efficiency (EQE) spectra (Fig. 3c), we found that the EQE of six cells in range of 300–600 nm were almost the same, obvious difference happened in long-wavelength region (650–850 nm). This hinted that the photogenerated carriers coming from longer-wavelength absorption was effectively transported and collected at the back contact. The increase of EQE in long-wavelength region predicted that MoS<sub>2</sub>-NMP layer improved the contact interface between CdTe and Au, reduced recombination of electron–hole pairs and enhanced the collection of holes around the back electrode. It indicates that MoS<sub>2</sub>-NMP layer is a good candidate for the back contact.

Table 1 Photovoltaic parameters of solar cells with different thicknesses of MoS<sub>2</sub>-NMP films as the back contact

No.	$J_{sc}^a$ (mA cm <sup>-2</sup> )	$V_{oc}^b$ (V)	FF <sup>c</sup>	PCE <sup>d</sup> (%)
Normal	22.2	0.733	68	11.1
1T-MoS <sub>2</sub>	24.3	0.743	66	11.9
2T-MoS <sub>2</sub>	25.0	0.731	66	12.1
3T-MoS <sub>2</sub>	25.9	0.752	70	13.7
4T-MoS <sub>2</sub>	23.7	0.749	73	12.9
5T-MoS <sub>2</sub>	22.0	0.734	66	10.6

<sup>a</sup>  $J_{sc}$ : short-circuit current density. <sup>b</sup>  $V_{oc}$ : open-circuit voltage. <sup>c</sup> FF: fill factor. <sup>d</sup> PCE: power conversion efficiency.



### The energy level study for CdTe cells

Fig. 4a shows the morphology of MoS<sub>2</sub>-based thin film. It presents a flocculent appearance, which is consistent with the amorphous phase determined by XRD above. The sectional view of the best cell, 3T-MoS<sub>2</sub>, were presented in Fig. 4b. It is clear that the thickness of MoS<sub>2</sub>-based thin film was not uniform because of the coarse surface of CdTe layer. The mean thickness was estimated as about 250 nm. Mo 3d XPS spectra were recorded in Fig. 4c. Mo 3d peak were basically extinguished below 220 nm, which is consistent with the result of Fig. 4b.

To figure out the energy level structure between MoS<sub>2</sub>-based thin film and CdTe layer, the valence band spectra depth profile were presented in Fig. 4e. The spectra above 200 nm were assigned to MoS<sub>2</sub>-based thin film. The spectra at 0 nm is not adopted because of the possible pollute from the external environment. The spectra at 110 nm and 220 nm are basically the same. So we regard them as the true spectra for MoS<sub>2</sub>-based thin film. According to the linear extrapolation method, we could determine the valence maximum (VBM) of MoS<sub>2</sub>-based thin film as  $E_{\text{VBM}} = 0.15$  eV. Then we could find the spectra move to the direction of high binding energy until 660 nm. So we could deduce that the spectra between 220 nm to 660 nm arise from the Cu doped CdTe region, and the region below 660 nm is regarded as the undoped CdTe layer. Similarly, the valence maximum (VBM) of the undoped CdTe layer was derived as  $E_{\text{VBM}} = 0.71$  eV. We could also deduce the offset between the valence band positions of CdTe and MoS<sub>2</sub>-based thin film is 0.56 eV ( $\Delta E_{\text{VB}} = 0.56$  eV), which is exactly the value of a band bending because of the gradient Cu doping. Using bulk band gaps of 1.45 eV for CdTe and 2.14 eV for MoS<sub>2</sub>-based thin film, the conduction band offset of  $\Delta E_{\text{CB}} = 1.25$  eV was deduced by the valence band offset.

According to the corresponding results, combining with the band gaps and work functions of CdTe and MoS<sub>2</sub>-based thin film, the energy level structure at the interface of CdTe/MoS<sub>2</sub>-based thin film could be illustrated in Fig. 4f. We could find that there is a good ohmic contact in the interface between CdTe layer and MoS<sub>2</sub>-based thin layer. Under an electrical field (0.56 eV), the holes in CdTe layer can rapidly be transported to MoS<sub>2</sub>-based thin layer. Without MoS<sub>2</sub>-based layer as the back contact, the electrical field intensity in the interface will be decreased from 0.56 eV to 0.46 eV because of the difference (0.1 eV) of work functions between Au film and MoS<sub>2</sub>-based layer, which weakens its ability to collect holes. Therefore compared with the traditional cell, holes could transport more quickly from CdTe layer to MoS<sub>2</sub>-based thin film, then to Au film. Meanwhile electrons was blocked to transport from CdTe layer to MoS<sub>2</sub>-based layer by a large potential barrier ( $\Delta E_{\text{CB}} = 1.25$  eV), which further reduces the recombination of holes and electrons at the interface. Therefore, we could conclude that the high performance of 3T-MoS<sub>2</sub> cell along with the biggest  $J_{\text{sc}}$  come from the matchable energy level of CdTe/MoS<sub>2</sub>-based thin film interface.

### Conclusions

In summary, a MoS<sub>2</sub>-based complex thin film was successfully fabricated by spin-coating. It was constructed by the

MoS<sub>2</sub>(NMP)<sub>3</sub> molecules as basic structure unit to stack in a nearly-parallel manner through S...H-C hydrogen bonds. It exhibits a very high work function (5.42 eV) with a p-type semiconductor character. More interestingly, a unique thickness-dependent conductivity was found, which might come from the fancy electronic structure of MoS<sub>2</sub>-based complex thin film with MoS<sub>2</sub>(NMP)<sub>3</sub> molecules as block units. When used it as the back contact of CdTe cells, it produced a high efficiency, which can perform PCE 2.6% higher than that of the traditional cell. The matchable energy level between MoS<sub>2</sub>-based film and CdTe layer could be responsible for this significant efficiency improvement. This work might open a new direction for the extensive application of two-dimensional transition metal dichalcogenides.

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